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67. A method comprising:
driving a microelectromechanical device to operate along a predetermined hysteresis
curve; and
using electrical energy to alter the hysteresis curve.

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68. The method of claim 67 in which the electrical energy comprises at least one of a
voltage waveform, voltage polarities, waveform timing, or charge buildup.

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69. The method of claim 67 in which the device is part of an array of devices and the
electrical energy is applied in line-at-a-time fashion.

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70. The method of claim 67 in which the electrical energy is applied in conjunction
with an applied DC bias voltage.

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71. The method of claim 67 in which the electrical energy offsets charge buildup on
the device.